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Bio Data Sheet

CONFIRMATION NO. 2644

SERIAL NUMBER 10/735,621	FILING DATE 12/16/2003 RULE ✓	CLASS 118	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 829-619
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APPLICANTS

Akira Shimizu, Nara, JAPAN;

Yuhsuke Fukuoka, Nara, JAPAN;

Yasushi Fujioka, Kyoto, JAPAN; Katsushi Kishimoto, Kyoto, JAPAN;

Katsuhiko Nomoto, Osaka, JAPAN;

** CONTINUING DATA *****

NONE *mtz*

** FOREIGN APPLICATIONS *****

JAPAN 2002-367402 12/18/2002 *mtz*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 03/24/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN ✓	SHEETS DRAWING 10 ✓	TOTAL CLAIMS 26 ✓	INDEPENDENT CLAIMS 6 ✓
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no Met after Allowance	Verified and Acknowledged Examiner's Signature <i>maurice francis</i> Initials <i>mtz</i>			

ADDRESS

23117

NIXON & VANDERHYE, PC

901 NORTH GLEBE ROAD, 11TH FLOOR

ARLINGTON, VA

22203

TITLE

Plasma CVD apparatus, and method for forming film and method for forming semiconductor device using the same

FILING FEE RECEIVED 1136	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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